

<b>LIST OF ART CITED BY APPLICANT</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>P-0604</b>		APPLN. SERIAL NO. <b>10/725,506</b>	
				APPLICANT(S) <b>Choong-Jae LEE</b>			
				FILING DATE <b>December 3, 2003</b>		GROUP <b>2615</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE	
	<b>6,229,994</b>	<b>05/08/2001</b>	<b>Pavet</b>	<b>455</b>	<b>90</b>	<b>02/04/1999</b>	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS		
	<b>2002/0128053</b>	<b>09/2002</b>	<b>Jung, Kwang Shin</b>	<b>455</b>	<b>575</b>	<b>03/07/2002</b>	
<b>U.S. PATENT APPLICATIONS</b>							
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS		
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	<b>CN 1233126</b>	<b>10/27/1999</b>	<b>China (English Abstract &amp; Full Chinese Text)</b>			<b>X</b>	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)</b>							
<b>Chinese Office Action dated June 1, 2007 (English and Chinese)</b>							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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